	L #	Hits	Search Text	DBs	Time Stamp
1	L1	252	(decision decid$3) near15 (maintenance repair$3 maintain$3 clean$3) near15 (apparatus instrument plant)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 10:49
2	L8	100	(decision decid$3) near15 (maintenance repair$3 maintain$3 clean$3) near15 (chamber sector)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 10:50
3	L15	345	1 8	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 10:50
4	L22	625205	(pump$3 blow$3 fan$4 suppl$3) near15 ("O.sub.2" oxygen air)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:30
5	L29	46	15 and 22	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 10:53
6	L36	245974	(add$3 addition circulat$3) near15 ("O.sub.2" oxygen air)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:32
7	L43	765111	22 36	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:32
8	L50	27805	(safe safety) near20 (air oxygen "O.sub.2")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:34
9	L57	14118	43 and 50	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:34
10	L64	496	57 and semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:37
11	L71	6782	43 same 50	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:34
12	L78	34990	(detect$3 sens$3) near10 ("O.sub.2" oxygen)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:36
13	L85	387	71 and 78	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:36
14	L99	14	92 and semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:37
15	L92	166	71 same 78	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/05/20 11:43